

FIG. 1

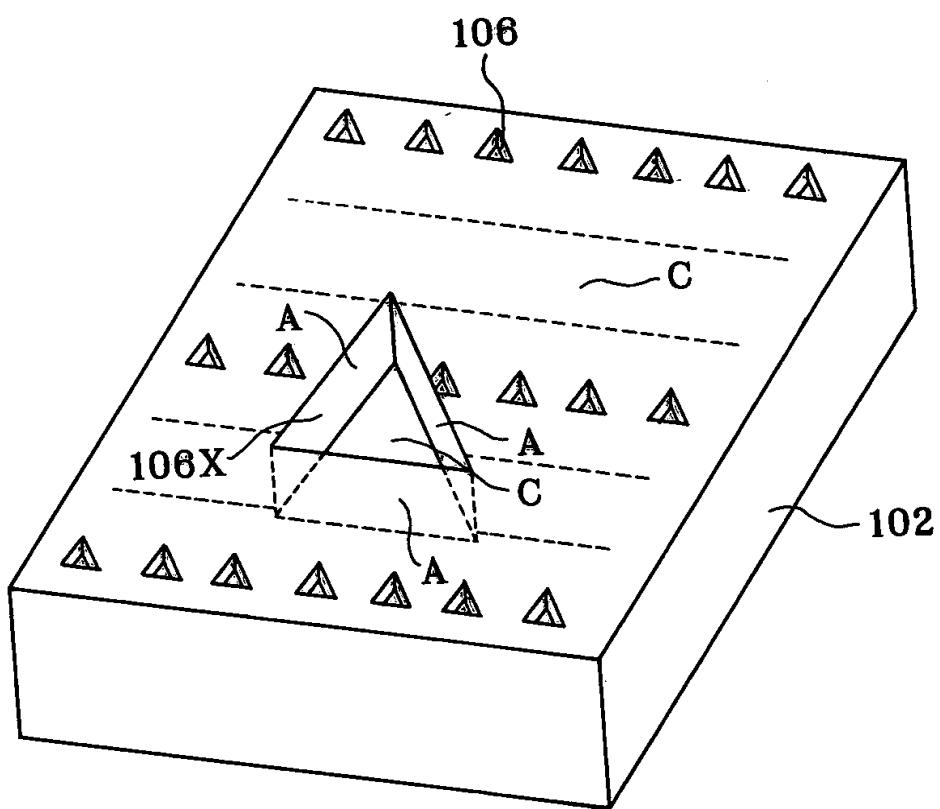


FIG. 2(a)

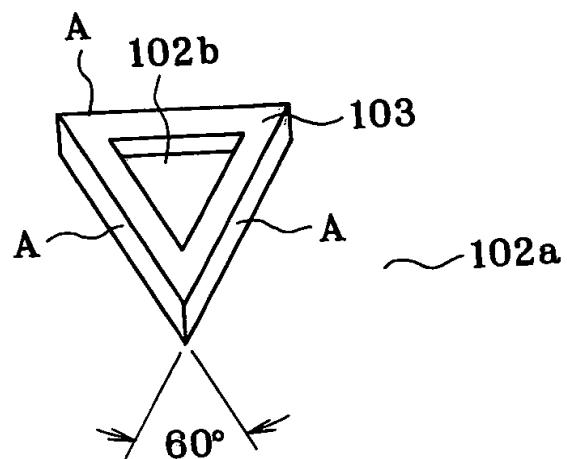


FIG. 2(b)

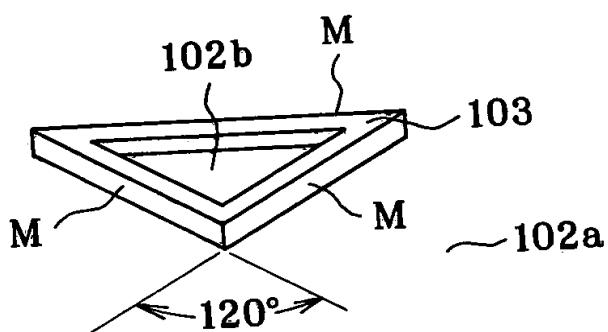


FIG. 2(c)

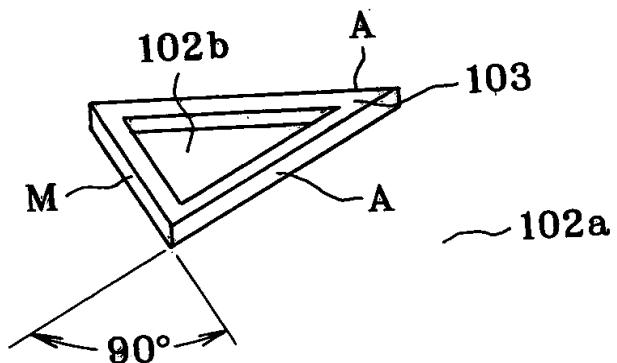
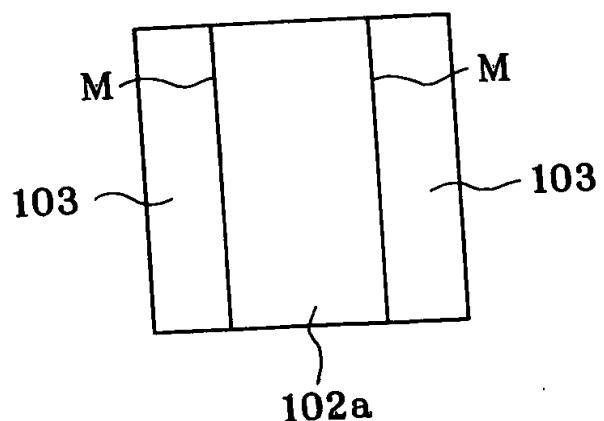


FIG. 3



NITRIDE SEMICONDUCTOR DEVICE, AND ITS FABRICATION PROCESS
Application No. [NEW] – Attorney Docket No. AZU.002
Inventors: Yukio NARUKAWA et al.

FIG. 4

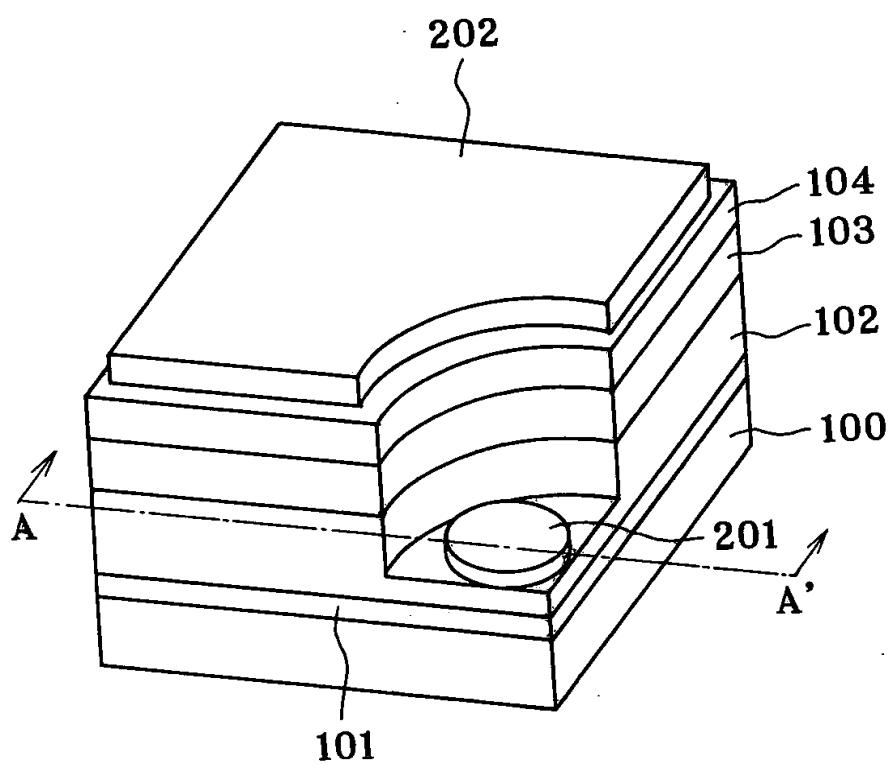
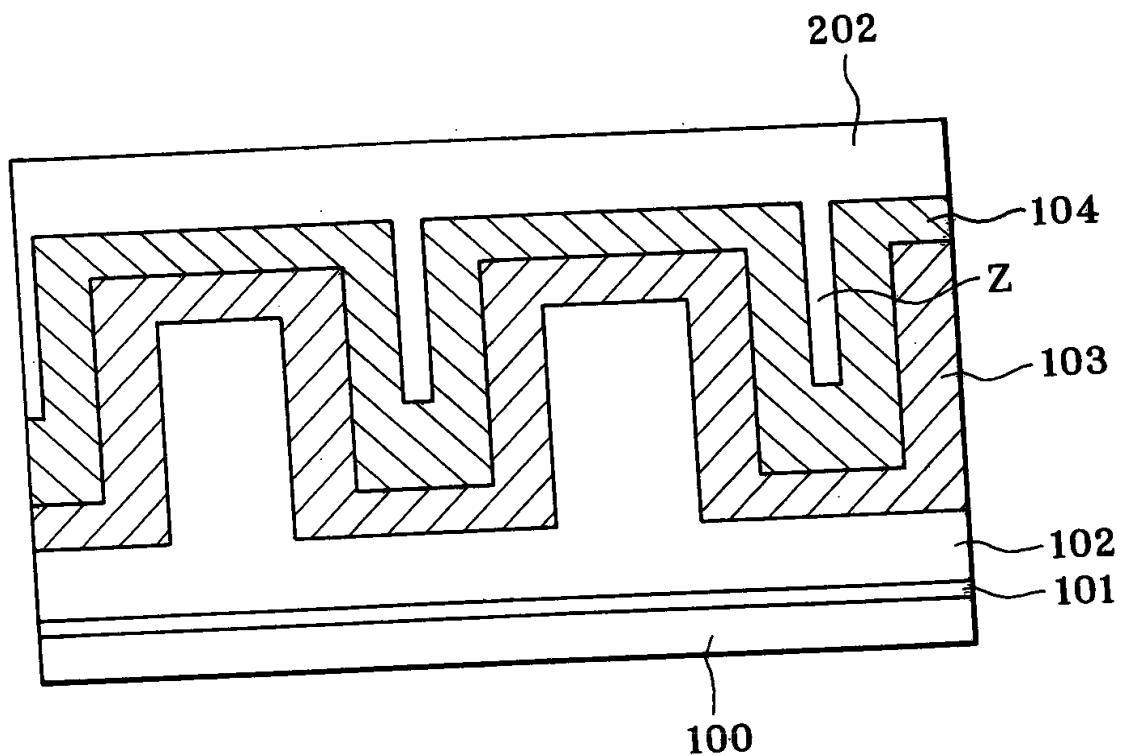


FIG. 5



NITRIDE SEMICONDUCTOR DEVICE, AND ITS FABRICATION PROCESS
Application No. [NEW] – Attorney Docket No. AZU.002
Inventors: Yukio NARUKAWA et al.

FIG. 6

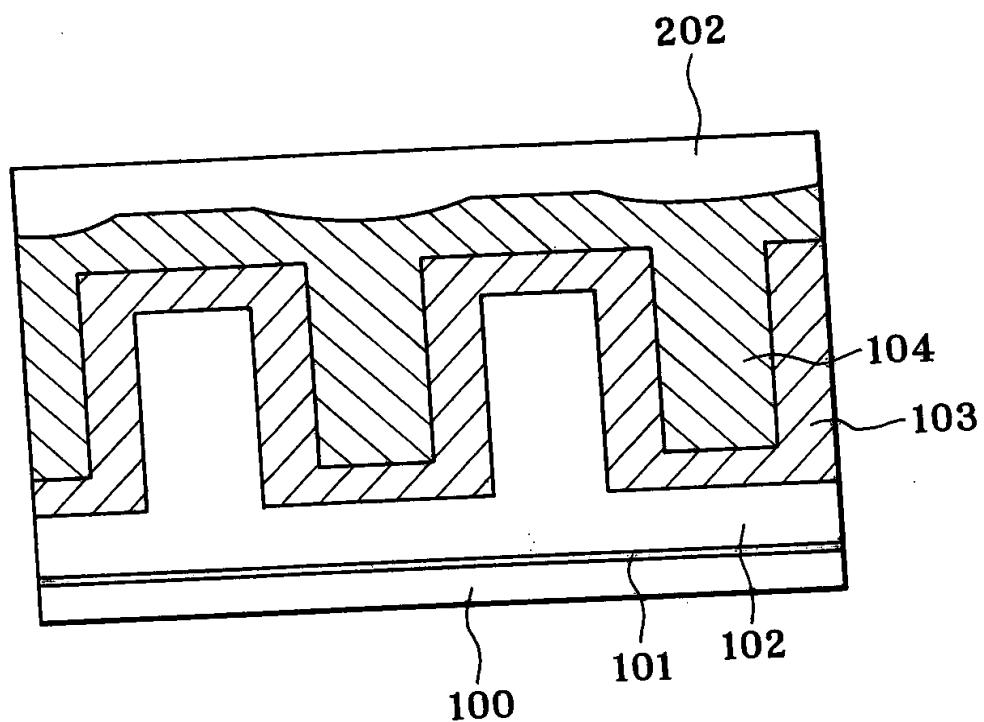


FIG. 7

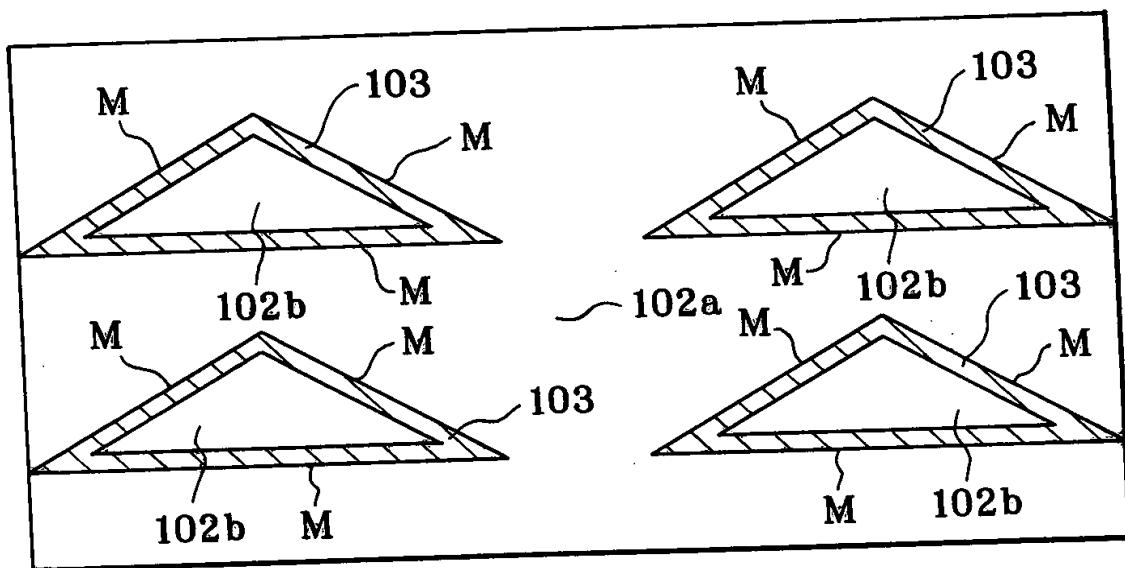


FIG. 8

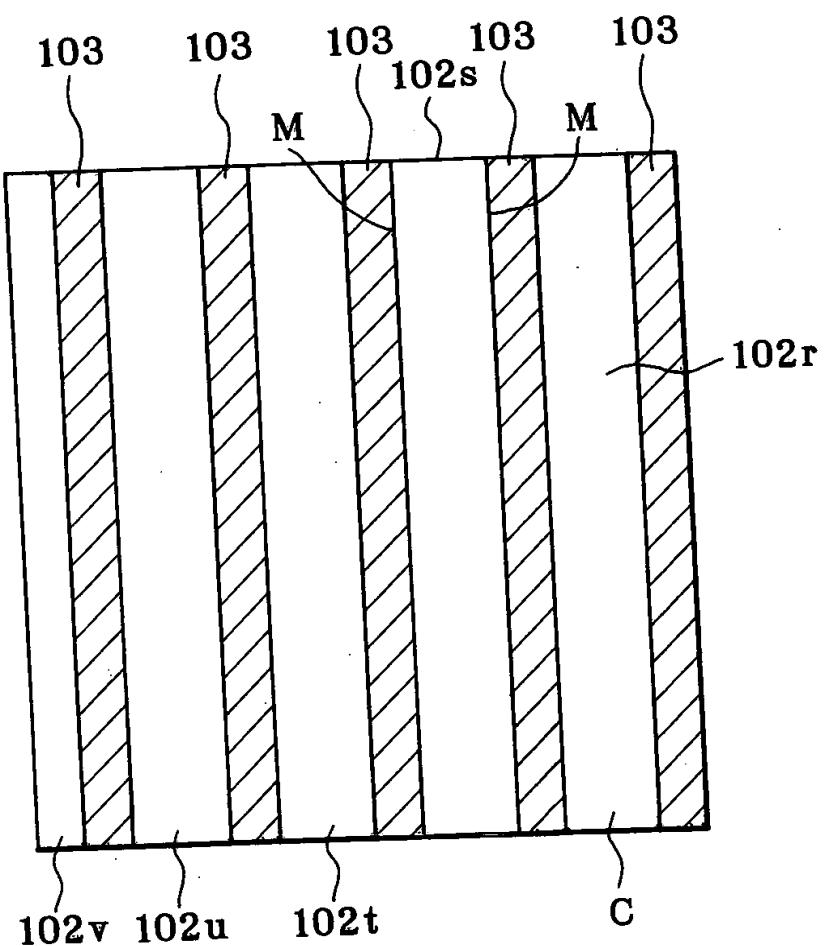


FIG. 9

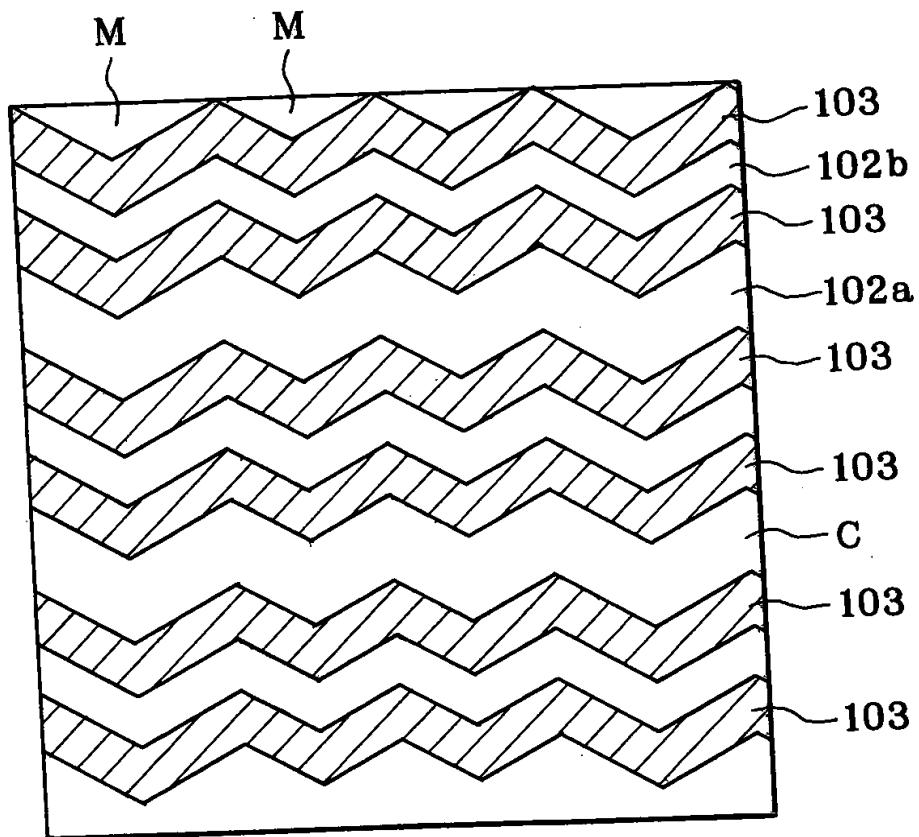


FIG. 10

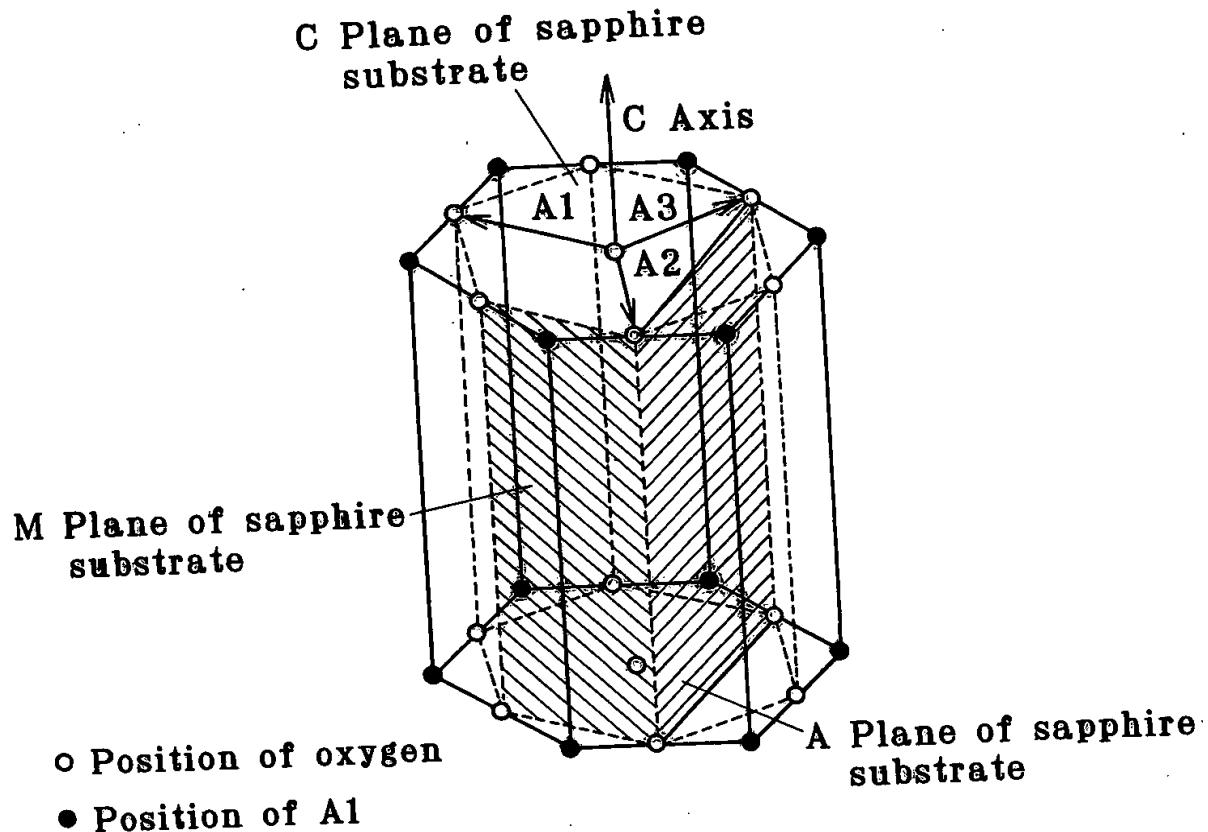


FIG. 11

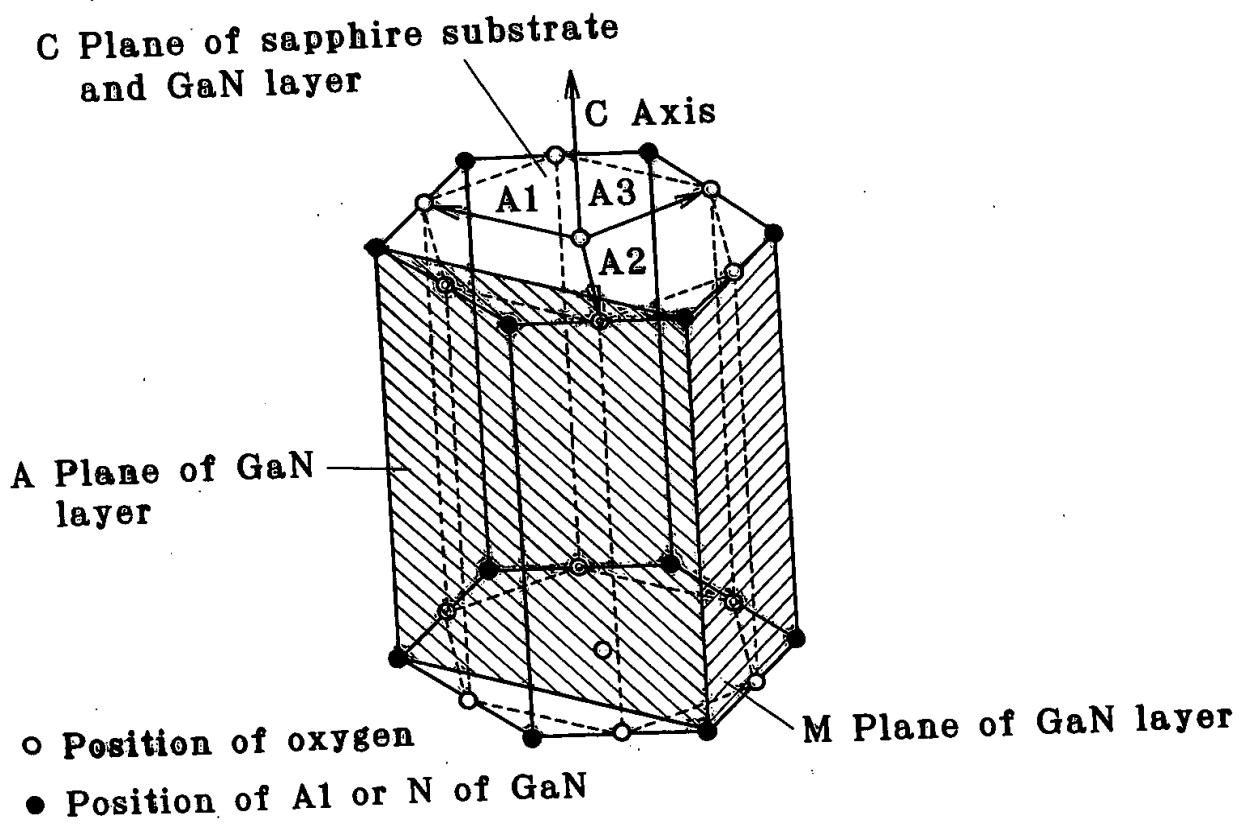


FIG. 12

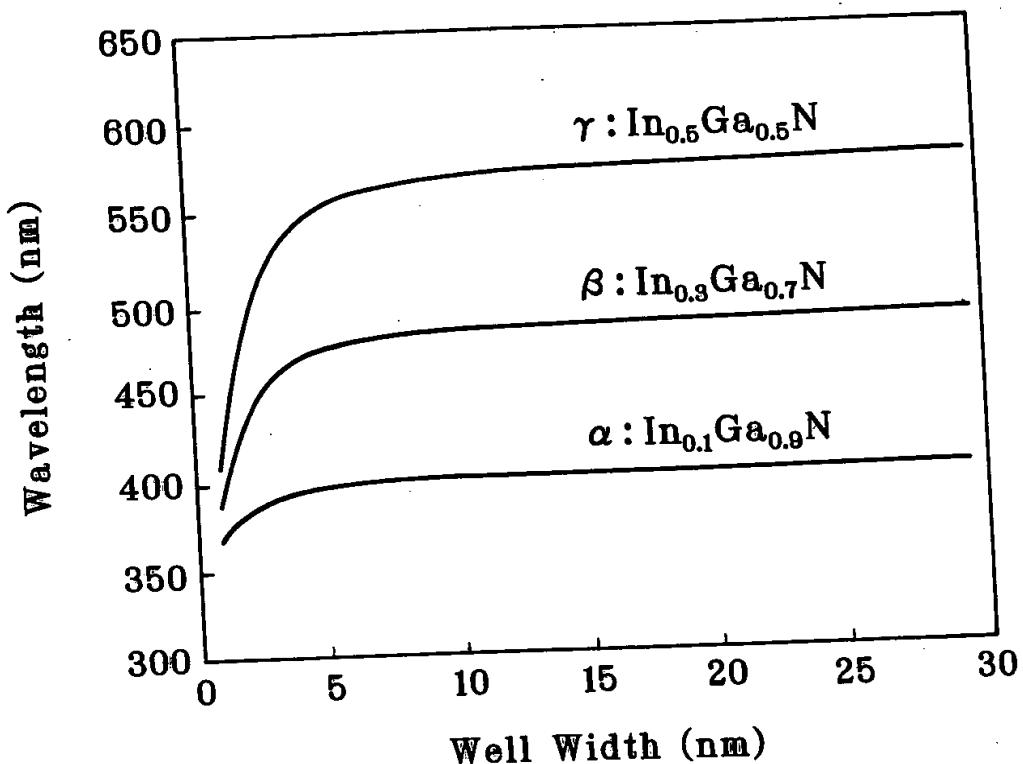


FIG. 13

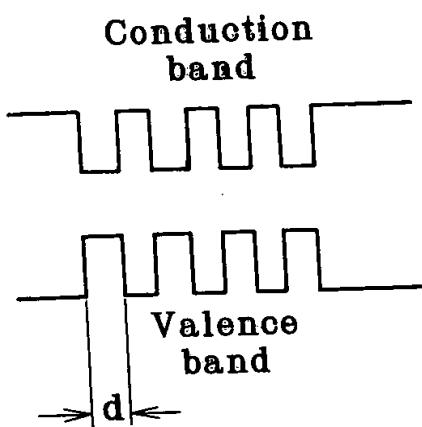


FIG. 14

